



Application No.: 09/943,955

PATENT/OFFICIAL

Docket No.: 5918/FPS/MMCS/APC/DV

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

SHANMUGASUNDRAM et al.

Serial No. 09/943,955

Filed: August 31, 2001

:
:
:
:
:
:
:

Group Art Unit: 1765


Examiner: L.T. Umez Eronini

For: FEEDBACK CONTROL OF CHEMICAL MECHANICAL POLISHING DEVICE
PROVIDING MANIPULATION OF REMOVAL RATE PROFILES

CERTIFICATION UNDER 37 C.F.R. § 1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelop addressed to: Mail Stop: Non-Fee Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date indicated below

6-9-05
Date of Deposit


Melissa Diaz

Mail Stop AF
Commissioner for Patents
U.S. Patent and Trademark Office
P.O. Box 1450
Alexandria, VA 22313-1450

REPLY AFTER FINAL REJECTION

Sir:

This Reply is responsive to an Office Communication dated December 30, 2004, and is accompanied by a petition for a three month extension of time to extend the period of response up to and including June 30, 2005.

Amendments to the Claims are reflected in the listing of claims begins on page 2.

Remarks/Arguments begin on page 11 of this paper.